



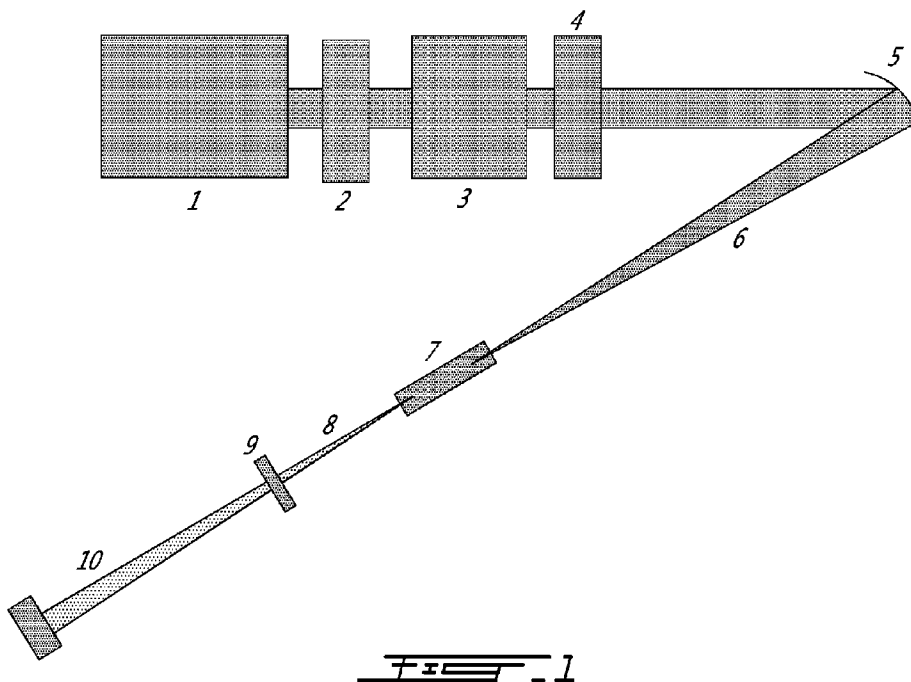
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(54) Titre : PROCEDE ET SYSTEME D'IMAGERIE PAR PHOTONS DE RAYONS X INTENSES ENTRAINEE PAR LASER
(54) Title: METHOD AND SYSTEM OF LASER-DRIVEN INTENSE X-RAY PHOTONS IMAGING



(57) **Abrégé/Abstract:**

A X-ray source, comprising a laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW, a pulse repetition rate of at least 1Hz; an optical compressor spectrally shaping the laser beam; focusing optics in the range between f#10 and f#15; and a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ; wherein the focusing optics focuses the laser beam in the gas target, and interaction of the focused laser beam with the gas target generates an X-ray beam, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λL is the laser wavelength, of at least 2 and a P/Pc ratio value of at least 20, with P being the beam power and Pc a critical power given by $P_c = 17 (n_c/n) \text{ GW}$ where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam.

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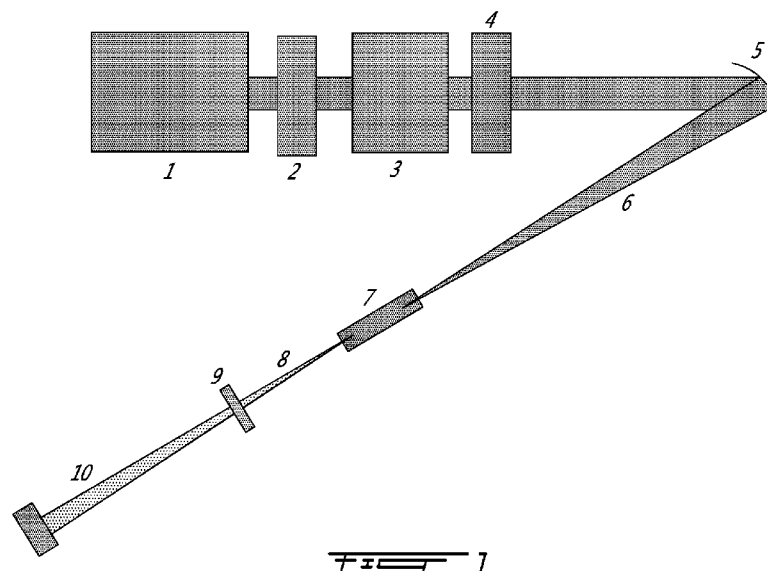
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TITLE OF THE INVENTION

Method and system of laser-driven intense X-ray photons imaging

FIELD OF THE INVENTION

[0001] The present invention relates to laser-driven X-ray photon sources. More specifically, the present invention is concerned with a method and a system of laser-driven intense X-ray photons imaging.

BACKGROUND OF THE INVENTION

[0002] In a plant production setting, a first issue is to see the interaction between plant's roots and the surrounding soil, which requires specific imaging technologies (X-rays or neutrons) with a high spatial resolution.

[0003] A second issue is to do a fast screening for selection. Plant breeders need to identify a phenotype in a production setting and determine if that phenotype is likely to be interesting to growers. A statistically significant number of samples, at least of order a thousand, typically need to be screened each growing cycle. Thus, for each plant line, no less than hundreds of screening samples per day must be achieved, which means about 10-12 minutes per plant.

[0004] High throughput phase contrast imaging for imaging of complex interfaces is being important in various fields, including plant science, and also material science and the biomedical field for example.

[0005] There is a need in the art for a method and system of laser-driven intense X-ray photons imaging.

SUMMARY OF THE INVENTION

[0006] More specifically, in accordance with the present invention, there is provided a X-ray source, comprising a laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW, a pulse repetition rate of at least 1Hz; an optical compressor spectrally shaping the laser beam; focusing optics in the range between $f\#10$ and $f\#15$; and a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ; wherein the focusing optics focuses the laser beam in the gas target, and interaction of the focused laser beam with the gas target generates an X-ray beam, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W}/\text{cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L

is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam.

[0007] There is further provided a method for imaging an object, comprising placing the target at a distance from an X-ray source, and imaging with in-line geometry on a detector, wherein the X-ray source comprises a laser of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW, a pulse repetition rate of at least 1Hz; an optical compressor spectrally shaping the laser beam; focusing optics in the range between #10 and #15; and a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ; the focusing optics focusing the laser beam in the gas target, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam.

[0008] There is further provided a system for X-ray imaging, comprising a high power femtosecond laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and a pulse repetition rate of at least 1Hz; an optical compressor spectrally shaping the laser beam; focusing optics in the range between #10 and #15; and a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ; with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam; and a target.

[0009] There is further provided a method for generating a plasma line, comprising propagating a laser beam from a laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and a pulse repetition rate of at least 1Hz, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam, within a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ; and applying a magnetic field.

[0010] There is further provided a method for guiding electromagnetic wave and electrical discharges, comprising propagating a laser beam from a laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and a pulse repetition rate of at least 1Hz, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_0/n) \text{ GW}$ where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam, within a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} .

[0011] There is further provided a method for object tomography, comprising imaging the object with X-ray beam generated by interaction of a laser beam with a gas target, wherein the laser beam is a spectrally shaped focused beam from a laser of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and a pulse repetition rate of at least 1Hz, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_0/n) \text{ GW}$ where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam, and the gas target has an electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} .

[0012] There is further provided a method for generating a X-ray source, comprising selecting a laser of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and pulse repetition rate of at least 1Hz; spectrally shaping the laser beam; focusing the laser beam; and interacting the focused laser beam with a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} , with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_0/n) \text{ GW}$ where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam.

[0013] There is further provided a high power laser system, comprising a beam shaper transforming an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile, wherein the beam shaper comprises at least one of: a graded reflective mirror, a graded transmission filter, a refractive transmission shaper, a spatial light modulator, and a deformable mirror to increase the laser pulse spatial contrast close to focus.

[0014] There is further provided a method for increasing a laser pulse spatial contrast close to focus, comprising shaping an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile.

[0015] Other objects, advantages and features of the present invention will become more apparent upon reading of the following non-restrictive description of specific embodiments thereof, given by way of example only with reference to the accompanying drawings.

BRIEF DESCRIPTION OF THE DRAWINGS

[0016] In the appended drawings:

[0017] FIG. 1 is a schematic view of a system according to an embodiment of an aspect of the present invention;

[0018] FIGs. 2 show laser beam parameters used to generate the X-ray measured with a laser energy of 4 J and a 70 nm spectral bandwidth: A) the frog trace, indicating a pulse duration of 20 fs; B) pulse spectrum; C) pulse duration; D) the near field; E) the near field profile; and F) the far field;

[0019] FIG. 3 shows laser pulse rise time of a laser system used to generate the X-ray as measured with a third order autocorrelator according to an embodiment of an aspect of the present invention;

[0020] FIG. 4 is a schematic view of the propagation of the laser inside a gas target according to an embodiment of an aspect of the present invention;

[0021] FIG. 5A shows a transverse shadowgraph measured at early time (17ps) and FIG. 5B shows a transverse shadowgraph measured at late time (360 ps), after the passage of a 34fs laser pulse ($P = 130\text{TW}$, 34fs pulse duration, $a_0 = 3$, $P/P_c = 30$, where P is the beam power and P_c is the critical power, focused at an intensity of $2 \times 10^{19}\text{W/cm}^2$ at the entrance of the gas, N_2 gas, electron density of $6 \times 10^{18}\text{cm}^{-3}$, 7mm long nozzle);

[0022] FIG. 6A shows the intensity variation along the laser propagation axis on a shadowgraph measured at late time, i.e. 360ps after the main laser, and showing focusing-defocusing effect through the entire gas length when a 20fs pulse is incident with a 200TW power ($a_0 = 5$, $P/P_c = 40$); FIG. 6B is a detail of FIG. 6A;

[0023] FIG. 7 shows the measured spatial wavelength of the radial fluctuation as a function of the gas electron density;

[0024] FIGs. 8 show the late expansion of the series of a micro plasma which develops in a cylindrical channel expanding like a blast wave: A) diameter as a function of time after the passage of the laser pulse; and transverse shadowgraphs B) after 360 ps; C) after 2480 ps; and D) after 7960s;

[0025] FIG. 9 shows the measured X-ray yield as a function of the self-guiding length;

[0026] FIG. 10 shows the measured number of photons N_x at 40KeV, obtained from measured X-ray spectra, as a function of the laser intensity I ; N_x scales as $I^{1/2}$;

[0027] FIG. 11 shows the measured X-ray yield as a function of the gas target electron density; the X-ray yield scales as $1/(P/P_c)^2$ (or $(1/n_e^2)$) when P/P_c is above 20;

[0028] FIG. 12 is a design chart deduced from an empirical scaling law and relating the laser power P (TW), the ratio P/P_c and the number of photons emitted at 40keV (ph/sr 0.1%BDW shot); the zone outside the shade areas defining a regime of interest ($a_0 \geq 2$ and $P/P_c \geq 20$);

[0029] FIG. 13 shows the scaling of the energy E_x in the X-ray energy band from 30keV to 40keV as a function of P/P_c for various values of the α parameter (P and P_c being expressed in TW) and for various laser powers;

[0030] FIG. 14A shows a phase contrast image of wheat head obtained in one laser shot;

[0031] FIG. 14B shows a phase contrast images of poplar obtained in one laser shot;

[0032] FIG. 15A is an image of a thick layer of soil;

[0033] FIG. 15B is an image of a thick layer of soil with nylon fibers embedded therein;

[0034] FIG. 15C is an image of the fibers embedded in the thick layer of soil retrieved with phase contrast information;

[0035] FIG. 15D shows a line out of an image of the fibers in air;

[0036] FIG. 15E shows a line out of the fibers (image (c)) in the soil;

[0037] FIG. 16 shows the signal to noise ratio S/N as a function of the shot number obtained from images of nylon spheres (density 1.15) embedded in a 1.5cm thick polyester resin (density 1.25) recorded with a magnification of 3; and

[0038] FIG. 17 is a phase contrast image of a mouse obtained in one laser shot and a magnification of 3.

DESCRIPTION OF ILLUSTRATIVE EMBODIMENTS

[0039] The present invention is illustrated in further details by the following non-limiting examples.

[0040] In a nutshell, there is presented a method and a system based on laser-based secondary sources of X-ray photons.

[0041] The Laser Wake-field Acceleration of electrons is based on the interaction of a short laser beam at relativistic intensity with a gas target, such as a gas or gas cell with cm length. A regime referred to as the bubble or blowout regime is reached for a laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18} \text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2. In this regime ($a_0 \geq 2$), the electrons are accelerated over a length referred to as the dephasing length L_d , at large energies up to hundreds of MeV and more, and the laser energy is efficiently transferred to the electrons via the Laser Wake-field Acceleration (LWFA) process over a length referred to as the depletion length L_p . Channel formation through self-focusing may be used to accelerate particles. Self-focusing and filamentation are obtained with ultrafast laser pulses when the beam power P is above a critical power P_c given by $P_c = 17 (n_c/n) \text{ GW}$ where n is the electron density and n_c is the critical density defining the electron density at which the plasma acts as a mirror reflecting the laser beam.

[0042] A system as illustrated in FIG. 1 for example comprises a laser 1, a beam shaper 2, an optical compressor 3, focusing optics 5, a gas target 7 and an object 9 to be imaged with in-line geometry, and a detection system 10.

[0043] The laser 1 is selected to simultaneously optimize the laser amplitude (a_0), the Laser-Wakefield Acceleration (LWFA) interaction lengths and the relativistic focusing-defocusing process. In the present

examples, the laser 1 is an 800nm multi-terawatt laser system of instantaneous power of at least about 80TW, for example in the range between about 80TW and about 250TW, with a laser energy on target in the range between about 2J and about 5J, a pulse duration of at most 40 fs, for example in the range between about 20fs and about 34fs, and a repetition rate of at least 1Hz. The pulse duration is modified by shaping the width of the laser spectrum in a range between about 50nm for the longer pulse, and about 90nm for the shorter pulse. Other techniques for pulse compression may be used to produce even shorter pulse duration.

[0044] Such laser system delivers a flat top beam profile. FIGs. 2 show an example of laser beam profiles in the near field (FIG. 2D) and the far field (FIG. 2F), and parameters measured at full energy with a laser energy of 4J and a laser pulse of 20fs. The far field distribution presents some low energy rings outside the main small spot (FIG. 2F).

[0045] Other profiles and parameters may be contemplated. FIG. 3 shows an example of a laser pulse rise time as measured with a third order autocorrelator. The contrast ratio is 10^{-6} at about 8 picoseconds before the peak of the pulse. A deformable mirror 4 at the output of the optical compressor 3 is used to monitor and control the laser beam phase front and the laser focusing.

[0046] The gas target 7 is typically a supersonic gas jet target.

[0047] The focusing optics 5 is selected in the range between $f\#10$ and $f\#15$, meaning between 10 and 15 times the beam diameter; in the present example an off-axis parabola of a 1.5m focal length focal is used, providing a focused laser beam 6 with minimized aberrations in the gas target 7, the nozzle length being varied between 3mm and 10mm, in a spot diameter of about $15\mu\text{m}$ for the central spot. The energy outside this most intense spot may contribute to produce a large volume of interaction. The on-target laser intensity I_L on the gas target 7 is varied between $5 \times 10^{18} \text{W/cm}^2$ and $5 \times 10^{19} \text{W/cm}^2$. The field amplitude a_0 is varied between 1.5 and 5. The gas jet target electron density after ionization by the laser beam is adjusted between 10^{18}cm^{-3} and 10^{19}cm^{-3} in order to explore a range of the ratio P/P_c between the beam power P and the critical power P_c between 4 and 80. The interaction of the focused laser beam 6 with the gas target 7 generates an X-ray beam 8. The object 9 placed at a distance from the gas target 7, acting as a X-ray source, is imaged with magnification with in-line geometry on the detector 10. The X-ray source optimization is realized by minimizing optical aberration to achieve laser propagation over the largest distance into the gas. Alignment and aberrations minimizing may be achieved as known in the art (see for example US patent application 2019/0165538), to control focusing of the laser beam and the generation of selected intensities on the gas target 7.

[0048] The measurements of electron spectra, X-ray angular profiles, X-ray spectra, X-ray yield and laser propagation inside the gas target were obtained simultaneously with various diagnostics for every single laser shot. An auxiliary beam with an appropriate delay line was used to realize transverse shadowgraphs of the plasma at different delays (ps – ns), with 15 μ m resolution, as well as imaging through Thomson scattering of the plasma. Electron and X-ray diagnostics include measurements of electron spectrum (100MeV – 2GeV), X-ray yield, X-ray spectrum (10keV – 100keV), X-ray beam divergence, X-ray beam profile and shape stability, X-ray beam pointing stability.

[0049] During the laser pulse rise time, the intensity increases, with some radial distribution, above the ionization threshold and any small intensity or electron density fluctuation across the beam can start to increase through a convective filamentation instability. This instability non-linearly couples the spatial intensity and the density fluctuations and usually develops when the plasma length L is sufficiently large. For an intensity of $10^{13}\text{W}/\text{cm}^2$ and 800nm wavelength, the threshold length, given by $L/\lambda_L > 2 \times 10^2 (I_{14} \lambda_{\mu\text{m}}^2)^{-1/3}$ where I_{14} is the laser intensity normalized to $10^{14}\text{W}/\text{cm}^2$, and λ_L is the laser wavelength in μm , is about 500 μm , which is reached in the gas target and experimental conditions used in Laser-Wakefield Acceleration (LWFA) experiments.

[0050] The focusing of a flat top or a super-gaussian laser pulse results in a radial intensity distribution extending well outside the main focal spot and producing in the focal plane a ionized channel of a large diameter, typically of a few hundreds of μm . The filamentation instability may develop inside such channel, generating some profiling of the plasma density before the arrival of the main pulse. The convective instability optimized radial fluctuation wave number k_x , corresponding to a spatial wavelength λ_x , is given by $k_x^2/k_0^2 = 0.25 (v_{os}/v_{th})^2 (n/n_c)$, where k_0 is the laser wave number, v_{os} is the quiver velocity of an electron in the laser field, and v_{th} is the thermal velocity. For an intensity of $10^{13}\text{W}/\text{cm}^2$, 800nm wavelength, a density of $6 \times 10^{18}\text{cm}^{-3}$ and a temperature of $T=20\text{eV}$, the radial fluctuation has a typical spatial wavelength λ_x of about 70 μm . The longitudinal spatial growth rate along the laser propagation axis is $K = (k_0/8)(v_0/v_{th})^2 (n/n_c)$, where n is the electron density and n_c is the critical density, and is about 0.5mm^{-1} for a 70 μm mode.

[0051] When the beam power P is well above the critical power P_c , the beam can undergo a number of focusing-defocusing cycles well beyond the theoretical Laser-Wakefield Acceleration (LWFA) dephasing and depletion lengths as shown schematically in FIG. 4. Transverse shadowgraphs measured at early time (17ps) (FIG.5A) and late time (360ps) (FIG.5B) after the passage of a 34fs laser pulse (130TW power, focused at an intensity of $2 \times 10^{19}\text{W}/\text{cm}^2$ at the entrance of the gas target, N_2 gas, electron density of $6 \times 10^{18}\text{cm}^{-3}$, 7mm long nozzle), show filamentation and self-focusing of the complex propagation of the laser

pulse. In this example, the focusing-defocusing modulations extends over a length L_{sf} which is about 4.2 mm, well beyond the dephasing and depletion lengths which are respectively around 1.3 and 2.6mm in the present case. With a 20fs pulse ($a_0 = 5$) and higher P/P_c ($P/P_c \sim 40$) the self-guiding effect is generated over a length L_{sf} of 7mm (FIGs. 6), limited by the nozzle length.

[0052] The radial distribution of the ionized region shows strong radial perturbations of the density whose imprint appears on the beam. The measured spatial wavelength of the radial fluctuation (with 20fs – 25fs pulse and peak intensity in the $4 \times 10^{19} \text{W/cm}^2$ - $4.5 \times 10^{19} \text{W/cm}^2$ range) shown in FIG. 7 decreases from 120 μm to 60 μm when the electron density n increases from 10^{18}cm^{-3} to 10^{19}cm^{-3} as $n^{-1/2}$, as expected from the scaling laws for the convective filamentation instability. The curve in FIG. 7 represents the calculated spatial wavelength for a laser intensity of 10^{13}W/cm^2 , reached in the pulse rise time, and a temperature of 20eV for the plasma produced by the radial intensity distribution.

[0053] The filamentation instability, by modulating the radial electron density profile of the gas target before the arrival of the main pulse during the rise time, may play an important role at higher peak power and laser intensities by assisting and increasing the self-guiding of the peak of the pulse. The large ionization channel and the filamentation effects are related to the intensity profile of a super-Gaussian distribution in the far field.

[0054] On longer time scales, each micro-plasma expands spherically. After some time, the micro-plasma expansions merge in a cylindrical channel expending radially as a Taylor-Sedov blast wave as shown in FIGs. 8.

[0055] In the system of FIG. 1, the beam shaper 2 is selected as a combination of optical elements including graded reflective mirror, graded transmission filter, refractive transmission shaper, spatial light modulator, deformable mirror, and/or spatial filtering, to transform the flat top or super-gaussian profile delivered by the laser into a Gaussian intensity distribution profile. A gaussian intensity distribution in the near field gives a similar gaussian distribution in the far field, which strongly reduces the radial extension of the ionization channel produced during the rise time of the laser and thus ensures that most of the laser energy is used efficiently to generate the self-guiding effect and bright X-rays. Before the compressor 3, at the output of the last amplification stage, it is thus used to mitigate the effect of the intensity spatial distribution in the far field and limit the energy spread outside the main focal spot in the far field.

[0056] The conjunction of very high P/P_c ratio, with P/P_c of at least over 20, and very short laser pulse, with pulse of at most 40fs, for example about 20 fs, allows to reach a self-guiding regime. The X-ray yield (Y) scales as $Y \sim L_{sf}^2$ as shown in FIG. 9. The X-ray spectra, recorded in the self-guiding regime, indicate that the number of photons N_x (in ph/(sr 0.1%BW shot) at 40keV scales as $N_x \sim I_L^{1/2}$ ($N_x = 0.13 I_L^{1/2} W/cm^2$) (FIG. 10). In addition, FIG. 11 shows that below a density value corresponding to a P/P_c ratio value of 20, the X-ray emission drops quickly when the density n and the ratio P/P_c are decreased, and no Betatron signal is observed at $10^{18}cm^{-3}$ ($P/P_c = 4.3$) indicating a weak self-guiding effect in the lower density regime. For $P/P_c \geq 20$ the X-ray yield scales as $Y \sim 1/(P/P_c)^2$ (or $Y \sim 1/n^2$) as shown in FIG. 11.

[0057] These results allow to extract, in the high P/P_c regime, where P/P_c is 20 or higher, a scaling law correlating the focusing-defocusing length L_{sf} and the photon number to the laser and gas target parameters. It can be deduced that $L_{sf} \sim a_0^{1/2} P_c$ which translates in (valid here for 40keV photons and $P/P_c \geq 20$) $N_x \sim \alpha(P) a_0/n^2$ or $N_x = 10^{10} a_0^5 (P/P_c)^{-2}$ where N_x is the number of photons at 40keV in ph/(sr 0.1%BW shot), P the laser power, a_0 the field amplitude, and n the gas target density.

[0058] A design chart shown in FIG.12 has been established for this self-guiding regime ($a_0 \geq 2$ and $P/P_c \geq 20$) of X-ray production from the scaling law, correlating the number of photons N_x at 40keV, for the present example, to the laser power P and the field amplitude a_0 , and to the gas target parameter (P_c). Starting from a laser power value (left vertical axis), the chart allows deducing the P/P_c ratio for a given density (dotted line). Then, the interaction of the P/P_c vertical line with a curve for a given a_0 indicates the number of photons expected for these parameters.

[0059] As an example, in the high P/P_c regime, the following parameters were measured for the X-ray source (200TW power, 2.5Hz repetition rate, $4 \times 10^{19} W/cm^2$, P/P_c around 40, N_2 gas, 7mm long nozzle): the critical energy, the slope of the synchrotron X-ray distribution spectrum, is in the range $E_c = 15$ keV to 25keV; the energy in the X-rays is 4μJ/shot in the 30keV-40keV band, the X-ray source diameter is 1.5μm (FWHM), the divergence of the X-ray beam is 50mrad x 50mrad, the X-ray source repetition rate is 2.5Hz, equal to the laser repetition rate. The beam spatial profile distribution, yield and pointing stabilities are around a few percent rms. The X-ray average power obtained is 10μW (in the 30-40keV band) and the photon number N_x (at 40keV) = 10^9 ph/(sr 0.1%BW shot). The average power at 40keV (2.5Hz) is 8×10^8 ph/(s mm² mrad² 0.1%BW) and the brilliance at 40keV is 1.6×10^{22} ph/(s mm² mrad² 0.1%BW), assuming 20fs X-ray pulse.

[0060] Similar design chart can be generated for different X-ray energies. A high throughput X-ray system for phase contrast imaging can thus be fully designed with the help of the design chart presented in FIG. 12.

[0061] Writing the scaling for the photon number as a function of the ratio P/P_c gives, for constant focusing parameters, $N_x \sim a_0^5 (P/P_c)^{-2}$. Scaling of the X-ray photon number N_x , and of the energy E_x , in the X-ray beam in the 30keV – 40keV band for example, as a function of the laser power, may be obtained by considering a trajectory for which $P/(P_c)^2$ is constant. Assuming constant focusing parameters and laser wavelength yields $E_x \sim \alpha^{-5/2} (P/P_c)^3$ where $\alpha = P/(P_c)^2$.

[0062] FIG. 13 shows of the energy E_x as a function of P/P_c for different values of the α parameter, P and P_c being expressed in TW, and for different laser powers. The points represent data from experiments realized at different laser powers (90TW, 120TW and 220TW) and with different α parameters (different powers for α between 4 and 5) and different α at constant power at 130TW. In these experiments, all the parameters (P , gas density, laser intensity I and E_x in the 30keV – 40keV band) were experimentally measured, and each data point represents an average of several shots with the same conditions.

[0063] The method and system were used to demonstrate phase contrast high throughput imaging of plants with an in-line geometry. The distance between the X-ray source 7 and the object 9 and the distance between the object 9 and the detector 10, combined with the parameters of the detector 10 determine the imaging regime, the spatial resolution, and the field of view. These last parameters determine the number of acquisitions shots for a specific object to be imaged. In the present examples, the distance between the X-ray source 7 and the object 9 was in a range between about 70 and 90 cm and the distance between the object 9 and the detector 10 was in a range between about 70 and 300 cm; a first detector used was a direct detection CDD 1300 x 1340 pixels (pixel of a side length of 20 μm), and a second detector used was an indirect detection 2084 x 2084 pixels detector (pixel of a side length of 24 μm).

[0064] Phase contrast images of wheat head and poplar obtained in one laser shot with a magnification of 3 are shown in FIG. 14A and FIG. 14B respectively. Comparison with images of same objects obtained with other techniques such as synchrotron or X-ray tubes for instance, indicates that the present method and system capture key features of a plant on a much faster data acquisition time. FIGs. 15 demonstrate that the X-ray imaging system allows visualization of transparent objects, such as nylon fibers with diameters ranging between 10 μm and 300 μm as illustrated, embedded inside an absorbing inhomogeneous and anisotropic environment, such as cm thick soil as illustrated. FIG.15A presents the image (one laser shot) of a thick layer of soil without the fibers; FIG.15B shows the image (one laser shot) of nylon fibers embedded in the

thick layer of soil; FIG. 15C shows the image of the fibers embedded in the thick layer of soil and retrieved with phase contrast information; the line out of an image of the fibers in air and of the same fibers in the soil are shown in respectively FIGs. 15D and 15E. Phase contrast information is still visible in FIG.15E, which indicates the potential of the method and the system.

[0065] 3D tomography of plants with phase contrast have been realized on a time scale responding to the plant breeders needs with the production of 720 images (1 image per $\frac{1}{2}$ degree) in 5mn.

[0066] The signal to noise ratio S/N, obtained with the X-ray source and deduced from images of nylon spheres (density 1.15) embedded in a 1.5cm thick polyester resin (density 1.25) and recorded with a magnification of 3, is presented in FIG. 16 as a function of the shot number accumulated to obtain an image. A signal to noise ratio S/N of about 16 is obtained in one shot, and the scaling ($S/N = 16 n_{sh}^{1/2}$) indicates that the signal to noise ratio S/N is proportional to the number of shots, demonstrating the good stability of the X-ray source.

[0067] The method can be used for in situ measure of the laser intensity in a long focal length configuration, as used herein, from the knowledge of the gas target density (P_c) and from the measurement of L_{sf} . Indeed, the scaling law gives $I_L \lambda^2 = 21.8 [L_{sf}/P_c]^4$ where I_L is in $10^{18}W/cm^2$, λ is in μm , L_{sf} in mm and P_c is in TW.

[0068] The combination of the present X-ray source emission high repetition rate, high number of photon per emission, homogeneity and stability of the X-ray beam, large field of view allowing to minimize the number of slices in which to image the object, hard X-ray energy ranges depending of the target parameters, for example 10 keV range for plant aerial parts, and 30-40 keV range for plant root system in the case of a plant, yields a method for fast screening and tomography of an object with a high spatial resolution.

[0069] The method was used for small animal single shot, high throughput phase contrast imaging and phase contrast 3D tomography as shown in FIG. 17.

[0070] The X-ray source as described herein may be used in conjunction with a magnetic field to obtain a compressed line plasma. As described hereinabove (see for example FIGs. 8), propagation of the laser beam within the gas jet target generates a series of micro-plasmas along the propagation axis of the laser; these micro-plasmas are compressed into a plasma line by application of a static or pulse magnetic field,.

[0071] Plasma canals provided by the generation of micro-plasmas along the propagation axis of the laser as a result of propagation of the laser beam within the gas jet target may further be used to generate low-density channels for guiding electromagnetic wave and/or electrical discharges.

[0072] There is provided a method and a system to improve the generation of laser-based secondary sources of photons or particles. The method and the system allow for spatial shaping of a laser beam used to generate intense beams of hard X-rays optimized for high throughput phase contrast imaging and rapid identification of phenotype in a plant production setting, for example. They allow an efficient use of all the laser energy, for example for the development of stand-alone system dedicated for lands and seeds high throughput X-ray phase contrast imaging.

[0073] The method and the system use laser pulses of at most 40 fs with a ratio of $P/P_c \geq 20$ to reach a self-guiding regime in which the laser drills a channel through the entire gas target length, well beyond the depletion and dephasing lengths, to produce very bright hard X-rays. The method and the system provide high throughput generation of LWFA-based betatron radiation in the hard x-ray range (10keV – 100keV).

[0074] The method allows the generation of a long plasma channel over the entire gas target. The laser beam undergoes many focusing-defocusing cycles well beyond the theoretical Laser Wake-field Acceleration (LWFA) depletion length. In this regime obtained when the ratio P/P_c is very large, the hard X-ray yield is proportional to the square of the self-guiding length which allows the production of high intensity hard X-ray beams appropriate for high throughput plant imaging. The Betatron X-ray source is characterized by a micrometric source size, a divergence of a few tens of mrad, a broad spectrum of synchrotron radiation with photon energies in the 10 keV – 100keV range, and a pulse duration similar to the femtosecond laser pulse duration.

[0075] A femtosecond high peak power laser system, delivering, at 800nm wavelength, pulse with duration (FWHM) equal or less than 20femtosecond with large energy larger than 3J, and a target comprising a gas of typically 10mm long were used. The quality of the laser beam controls the self-focusing and self-guiding length of the beam, which can then extend the X-ray production length well beyond the theoretical Laser Wake-field Acceleration (LWFA) depletion length. The laser pulse is focused at relativistic intensities (larger than 10^{18}W/cm^2) with a field amplitude $a_0 \geq 2$ to achieve the well-known Bubble regime. A key issue is to achieve a ratio $P/P_c \geq 20$ to reach this novel regime where the self-guiding effect and focusing-defocusing modulations are maintained over a length which is the total length of the gas target.

[0076] A unique regime of interaction is obtained, with focusing-defocusing self-guiding process maintained over the entire gas target length, by the conjunction of focusing the laser pulse inside the gas with a field amplitude a_0 larger than 2, using a very high P/P_c ratio of at least 20 and a very short laser pulse of at most 40fs, typically about 20fs.

[0077] A scaling law is provided, correlating the focusing-defocusing length L_{sf} and the photon number to the laser and gas target parameters. A design chart has been established for this regime of X-ray production from the scaling law, correlating the number of X-ray photons at a given energy to the laser power P and the field amplitude a_0 , and to the gas target parameter (P_c).

[0078] The present invention provides the generation of high intensity beam of hard X-rays optimized for high throughput plant phase contrast imaging and allowing a rapid identification of phenotype in a plant production setting. The system and method have been used to realize phase contrast high throughput imaging of plants with an in-line geometry and very fast 3D phase contrast tomography compatible with plant production setting.

[0079] A number of applications may be considered other than in the plant and seed domains, such as, for example, measuring in situ the laser intensity in a long focal length configuration; doing small animal single shot, high throughput imaging and phase contrast 3D tomography; shaping and compressing plasmas; producing plasma channels to guide discharges; and material nondestructive imaging.

[0080] The scope of the claims should not be limited by the embodiments set forth in the examples, but should be given the broadest interpretation consistent with the description as a whole.

Claims

1. A X-ray source, comprising:
 - a laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW, a pulse repetition rate of at least 1Hz;
 - an optical compressor spectrally shaping the laser beam;
 - focusing optics in the range between f#10 and f#15; and
 - a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ;

wherein said focusing optics focuses the laser beam in the gas target, and interaction of the focused laser beam with the gas target generates an X-ray beam, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and P/Pc ratio value of at least 20, with P being the beam power and Pc a critical power given by $P_c = 17 (n_c/n) \text{ GW}$ where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam.
2. The X-ray source of claim 1, wherein said focusing optics is an off-axis parabola.
3. The X-ray source of claim any one of claims 1 and 2, wherein said gas target is one of a supersonic gas jet target and a gas cell target.
4. The X-ray source of claim any one of claims 1 to 3, further comprising a beam shaper transforming an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile.
5. The X-ray source of claim any one of claims 1 to 3, further comprising a beam shaper transforming an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile, wherein the beam shaper comprises at least one of: a graded reflective mirror, a graded transmission filter, a refractive transmission shaper, a spatial light modulator, and a deformable mirror.
6. The X-ray source of claim any one of claims 1 to 5, further comprising a deformable mirror at the output of the optical compressor, said deformable mirror controlling the laser beam phase front and laser focusing.
7. A method for imaging an object, comprising placing the target at a distance from an X-ray source, and imaging with in-line geometry on a detector, wherein the X-ray source comprises a

laser of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW, a pulse repetition rate of at least 1Hz; an optical compressor spectrally shaping the laser beam; focusing optics in the range between f#10 and f#15; and a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ; the focusing optics focusing the laser beam in the gas target, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W}/\text{cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/Pc ratio value of at least 20, with P being the beam power and Pc a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam.

8. The method of claim 7, comprising transforming an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile.

9. The method of any one of claims 7 and 8, comprising selecting at least one of: a distance between the X-ray source and the object; a distance between the object and the detector, and parameters of the detector.

10. A system for X-ray imaging, comprising:
 a high power femtosecond laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and a pulse repetition rate of at least 1Hz;
 an optical compressor spectrally shaping the laser beam;
 focusing optics in the range between f#10 and f#15; and
 a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ; with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W}/\text{cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/Pc ratio value of at least 20, with P being the beam power and Pc a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam; and
 a target.

11. The system of claim 10, further comprising a beam shaper transforming an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile.

12. The system of any one of claims 10 and 11, further comprising a deformable mirror at the output of the optical compressor, said deformable mirror controlling the laser beam phase front and laser focusing.

13. A method for generating a plasma line, comprising propagating a laser beam from a laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and a pulse repetition rate of at least 1Hz, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam, within a gas jet, of electron density after ionization in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} ; and applying a magnetic field.

14. A method for guiding electromagnetic wave and electrical discharges, comprising propagating a laser beam from a laser, of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and a pulse repetition rate of at least 1Hz, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam, within a gas jet, of electron density after ionization in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} .

15. A method for object tomography, comprising imaging the object with X-ray beam generated by interaction of a laser beam with a gas target, wherein the laser beam is a spectrally shaped focused beam from a laser of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and a pulse repetition rate of at least 1Hz, with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least 20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam; and the gas target has an electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} .

16. A method for generating a X-ray source, comprising selecting a laser of a pulse duration of at most 40 fs, instantaneous power of at least about 80TW and pulse repetition rate of at least 1Hz; spectrally shaping the laser beam; focusing the laser beam; and interacting the focused laser beam with a gas target of electron density after ionization by the laser beam in a range between 10^{18}cm^{-3} and 10^{19}cm^{-3} , with a focused laser amplitude a_0 , given by $a_0 = 0.855 [I_L (10^{18}\text{W/cm}^2) \lambda_L^2 (\mu\text{m})]^{1/2}$, where I_L is the on-target laser intensity and λ_L is the laser wavelength, of at least 2 and a P/P_c ratio value of at least

20, with P being the beam power and P_c a critical power given by $P_c = 17 (n_c/n)$ GW where n is the electron density and n_c is a critical electron density at which the plasma acts as a mirror reflecting the laser beam.

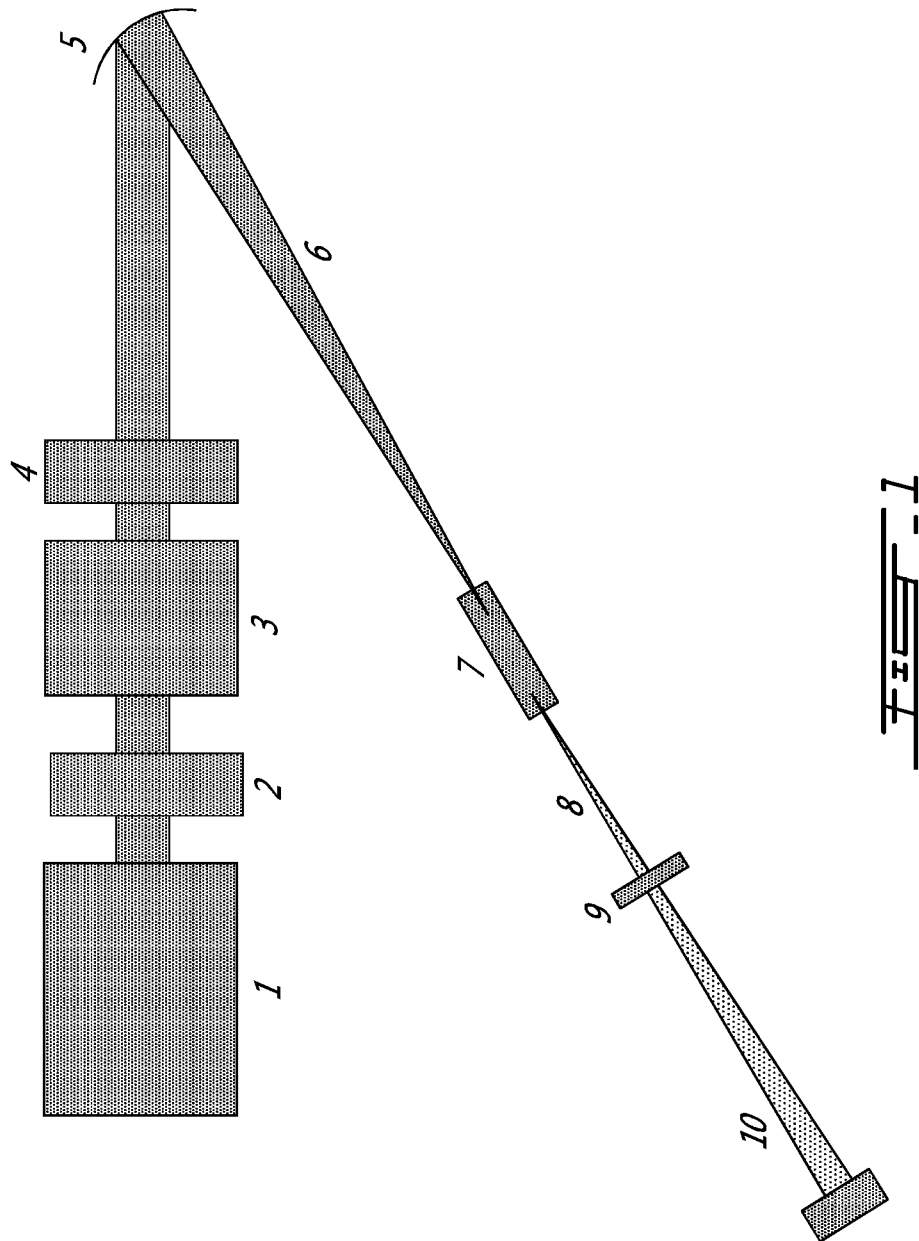
17. The method of claim 16, further comprising shaping an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile.

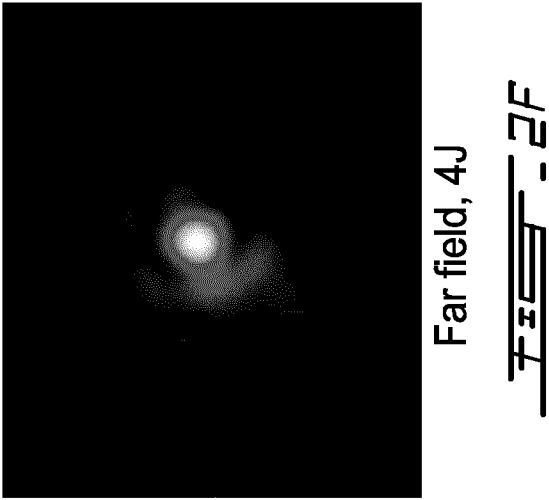
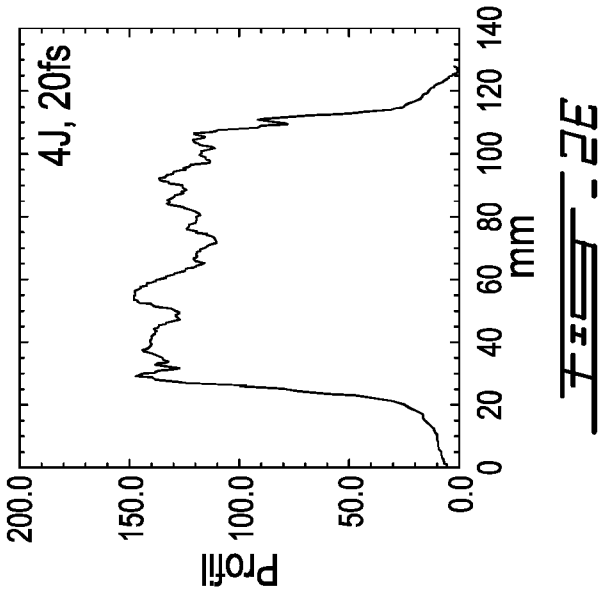
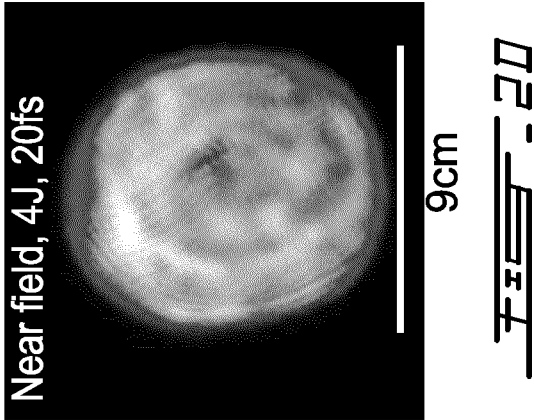
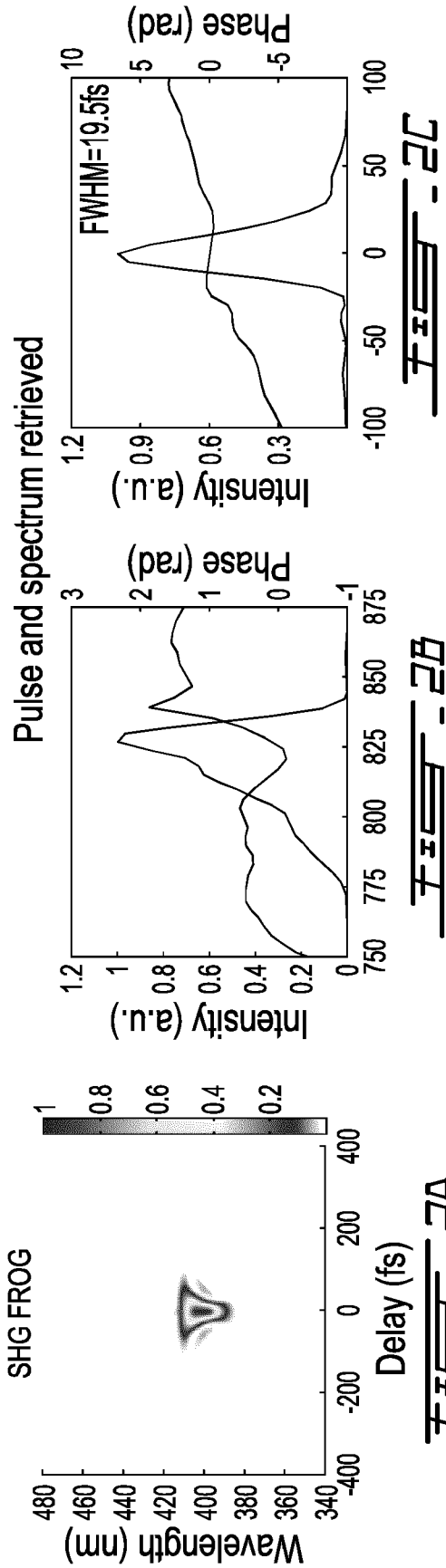
18. The method of claim 16, further comprising shaping an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile; and determining a number of photons of the X-ray source as a function of the laser power and the gas target of electron density.

19. A high power laser system, comprising a beam shaper transforming an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile, wherein the beam shaper comprises at least one of: a graded reflective mirror, a graded transmission filter, a refractive transmission shaper, a spatial light modulator, and a deformable mirror to increase the laser pulse spatial contrast close to focus.

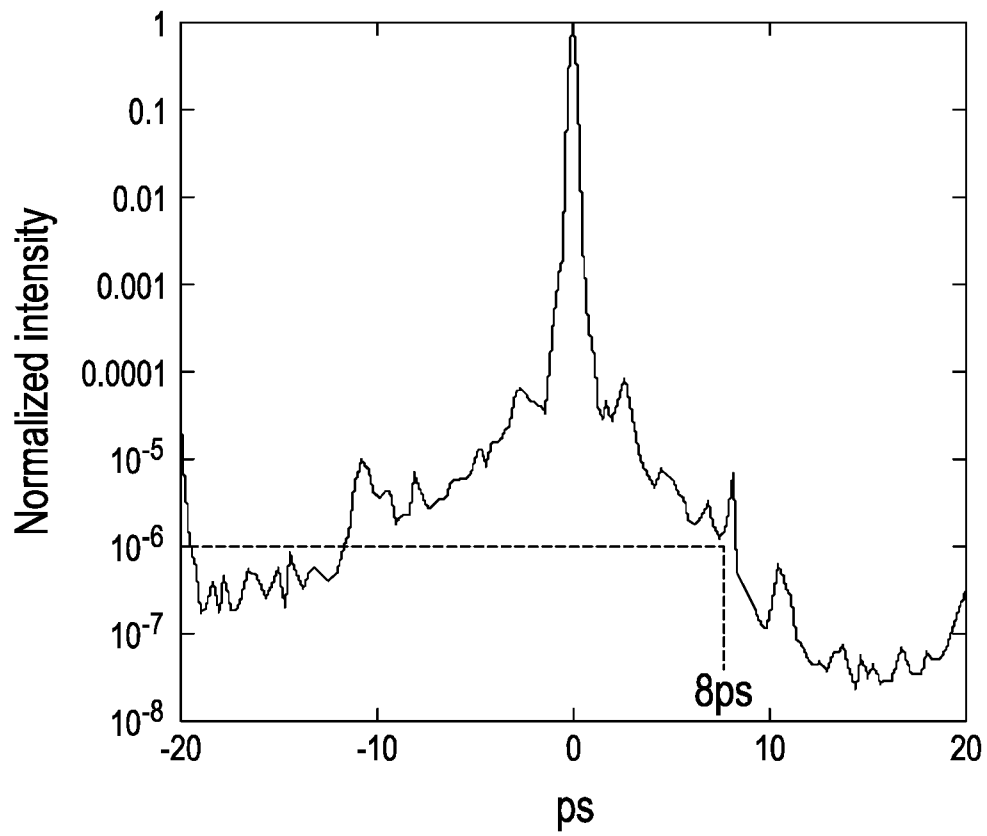
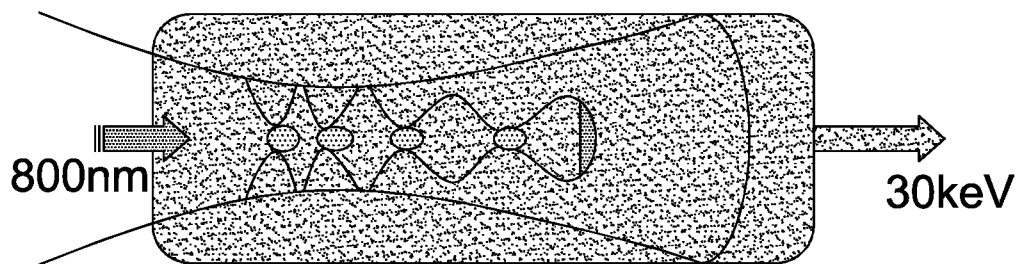
20. A method for increasing a laser pulse spatial contrast close to focus, comprising shaping an intensity distribution profile of the laser pulse into a Gaussian intensity distribution profile.

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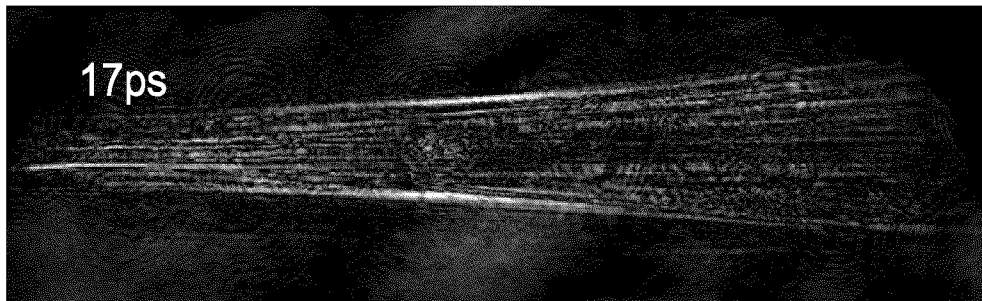
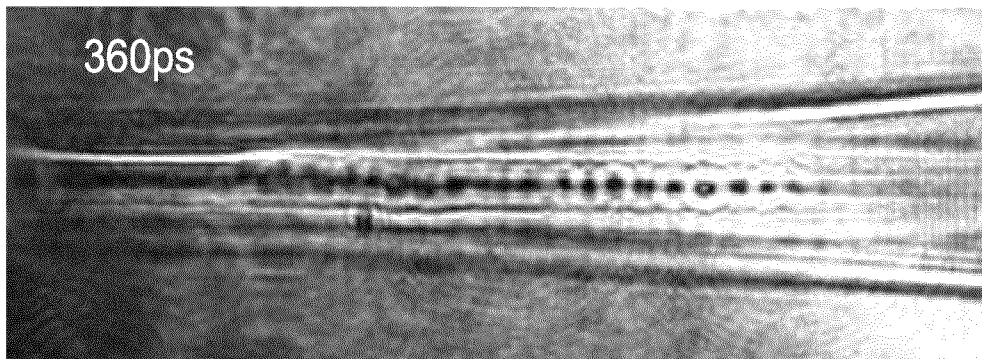
Figure 1



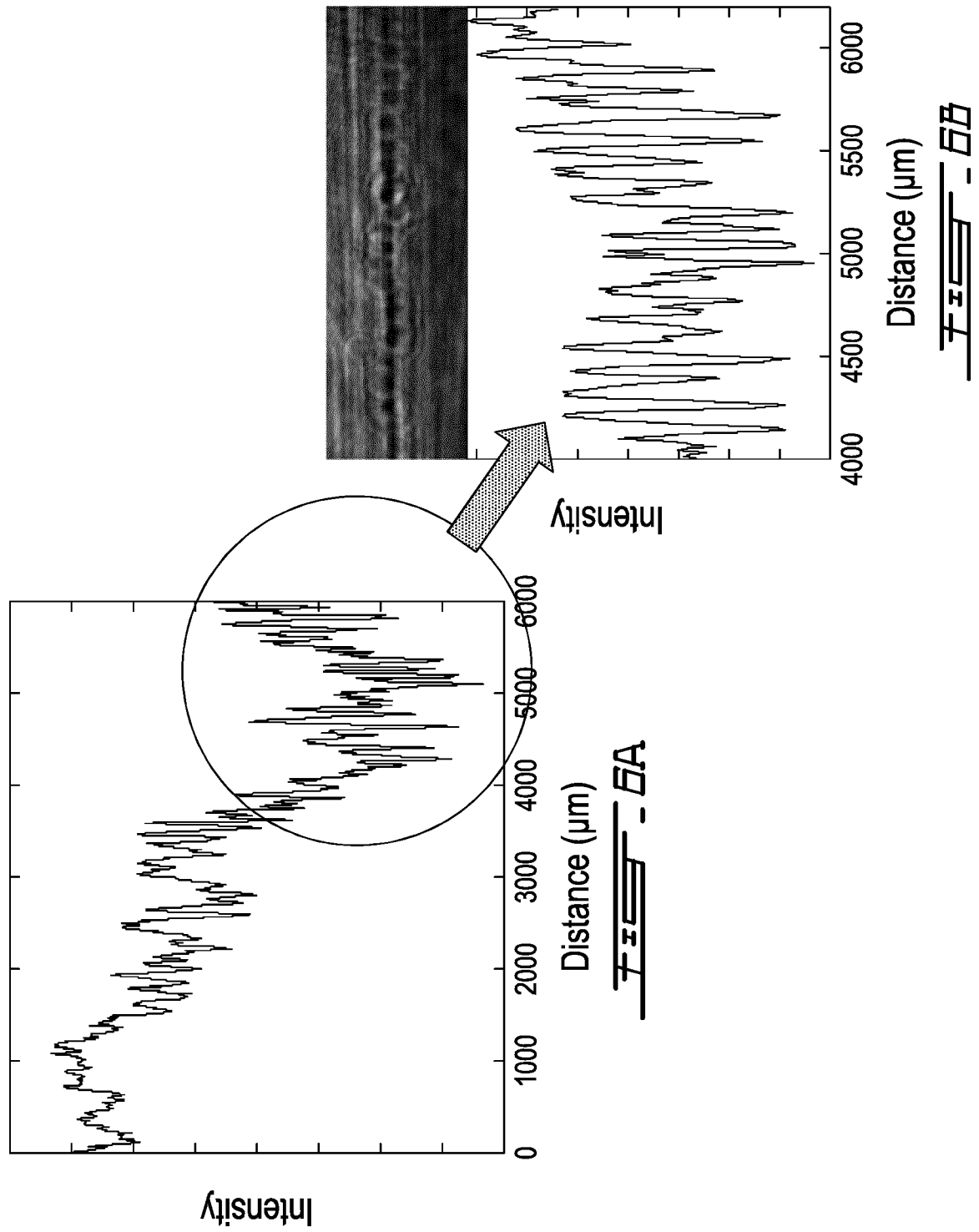
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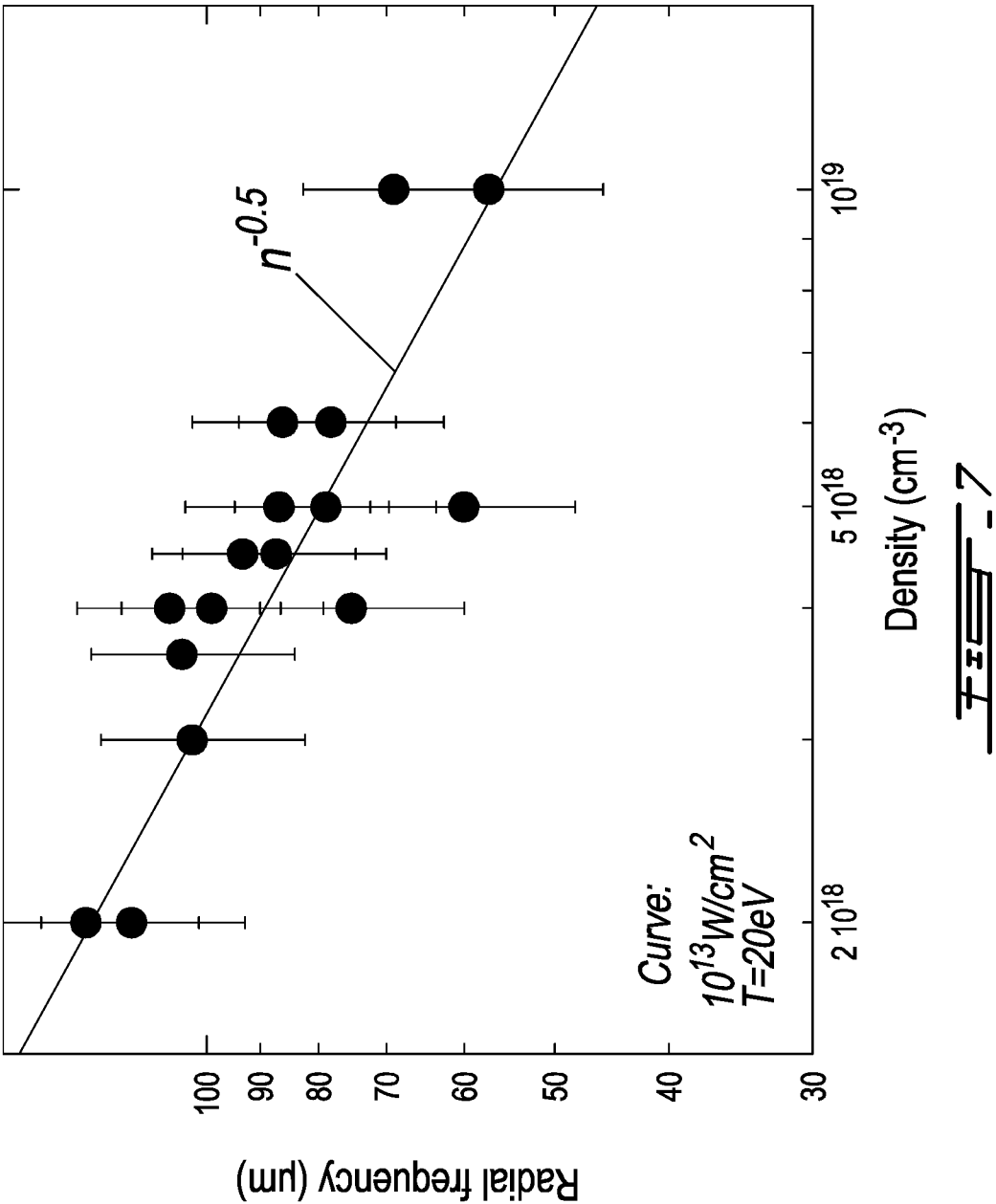
FIG. 3FIG. 4

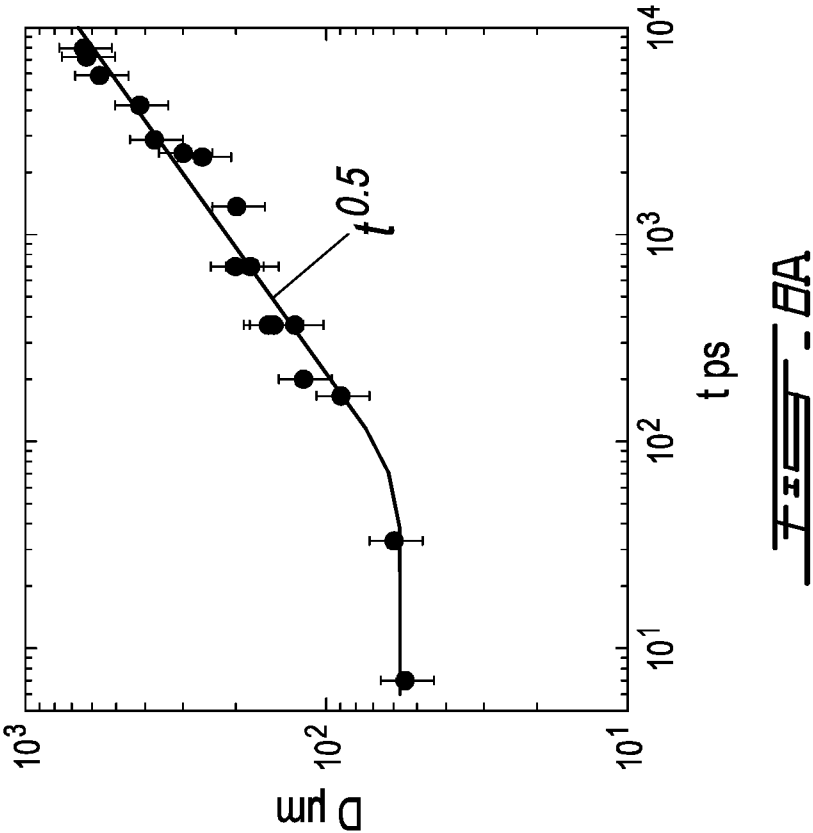
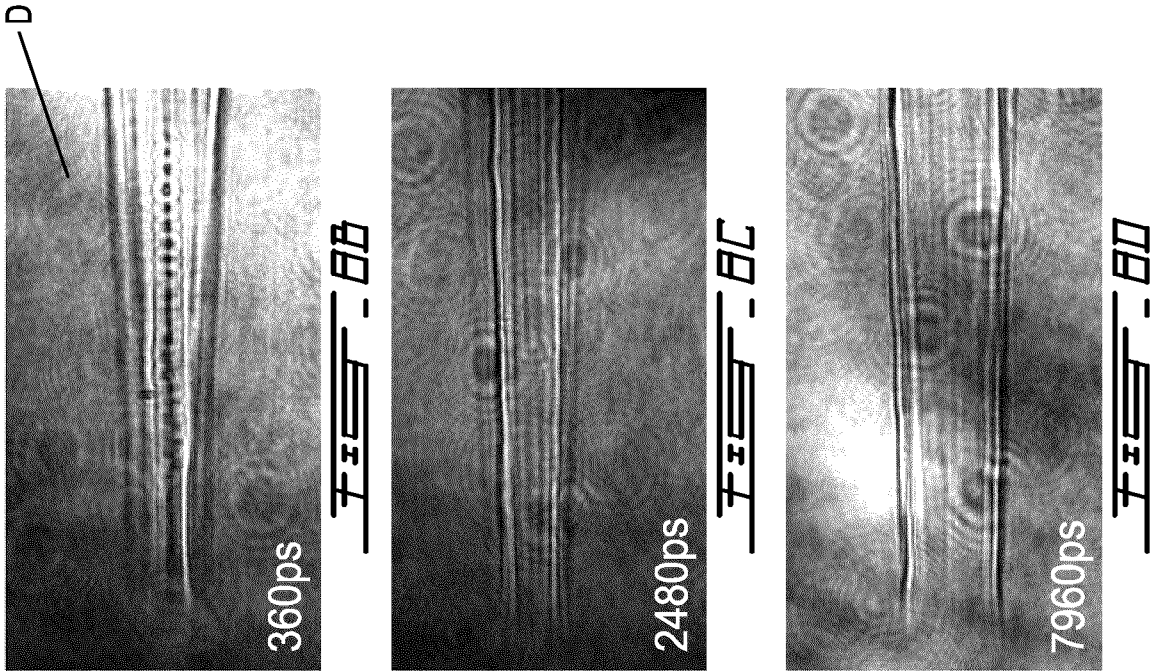
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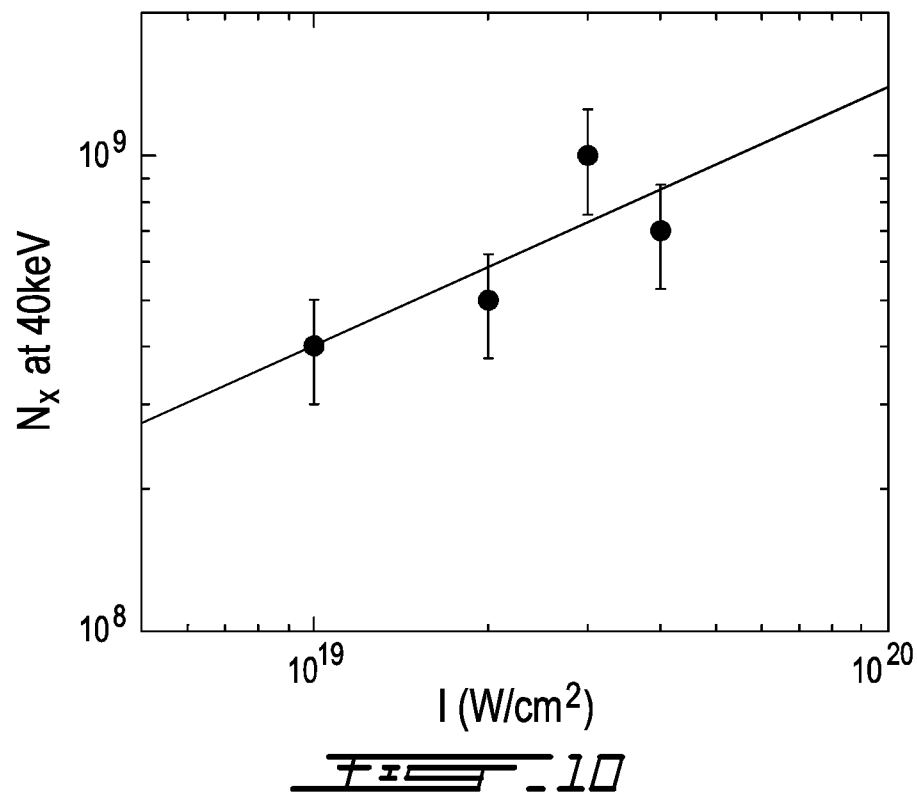
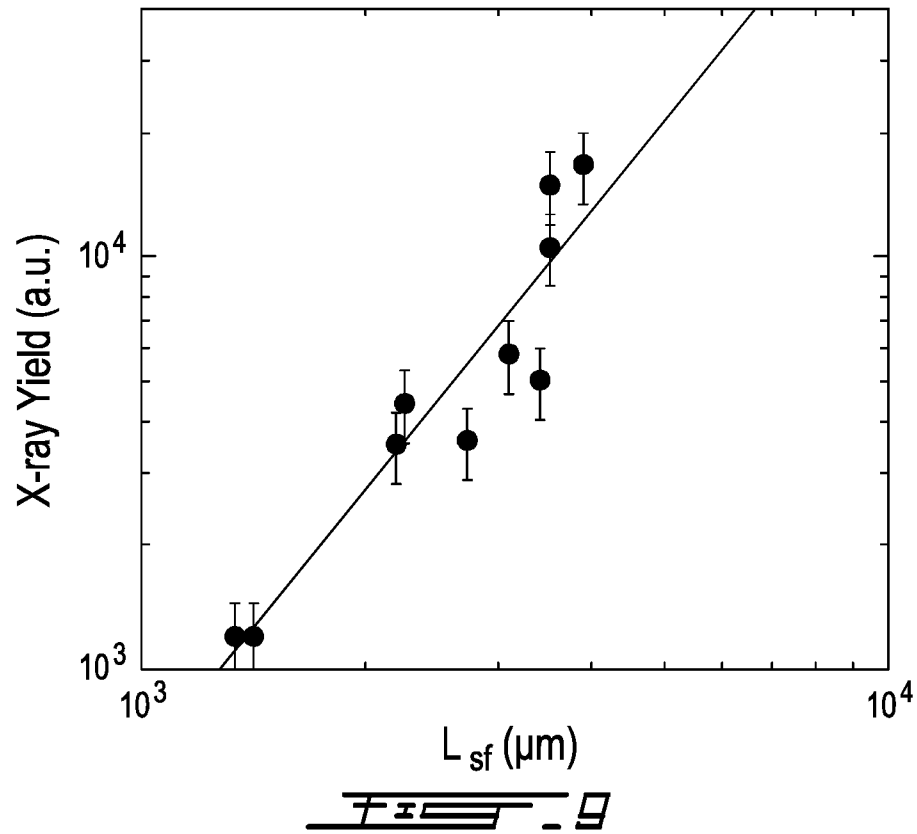
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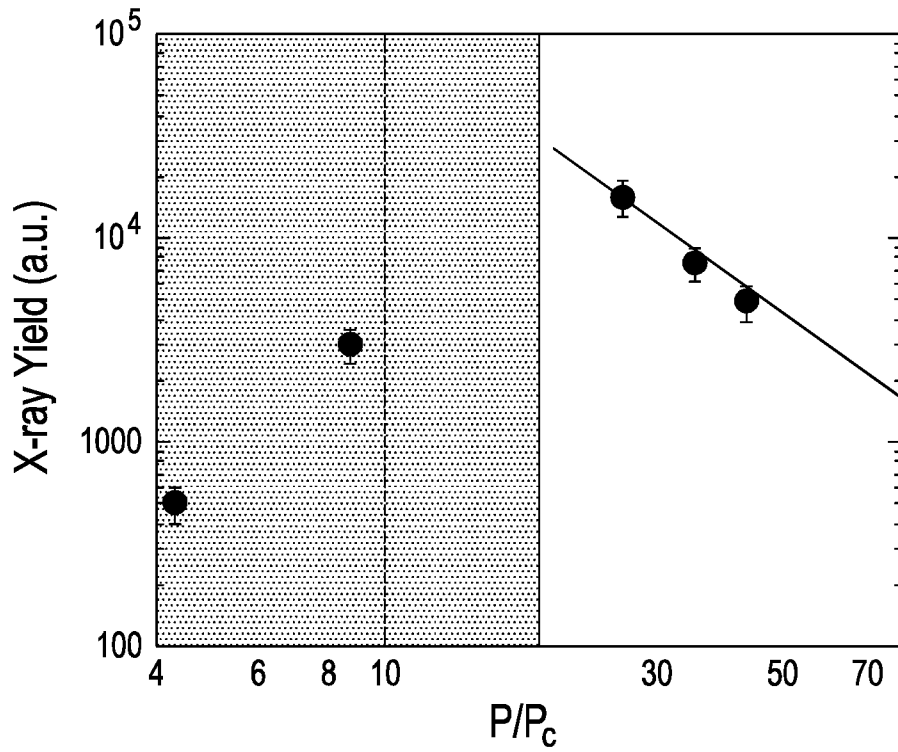
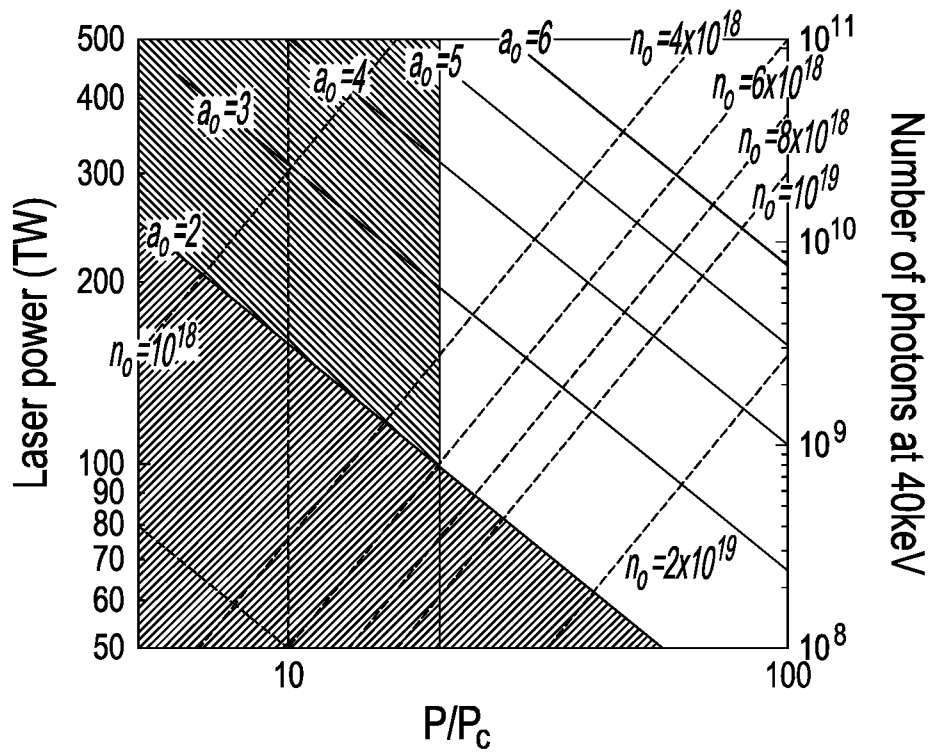


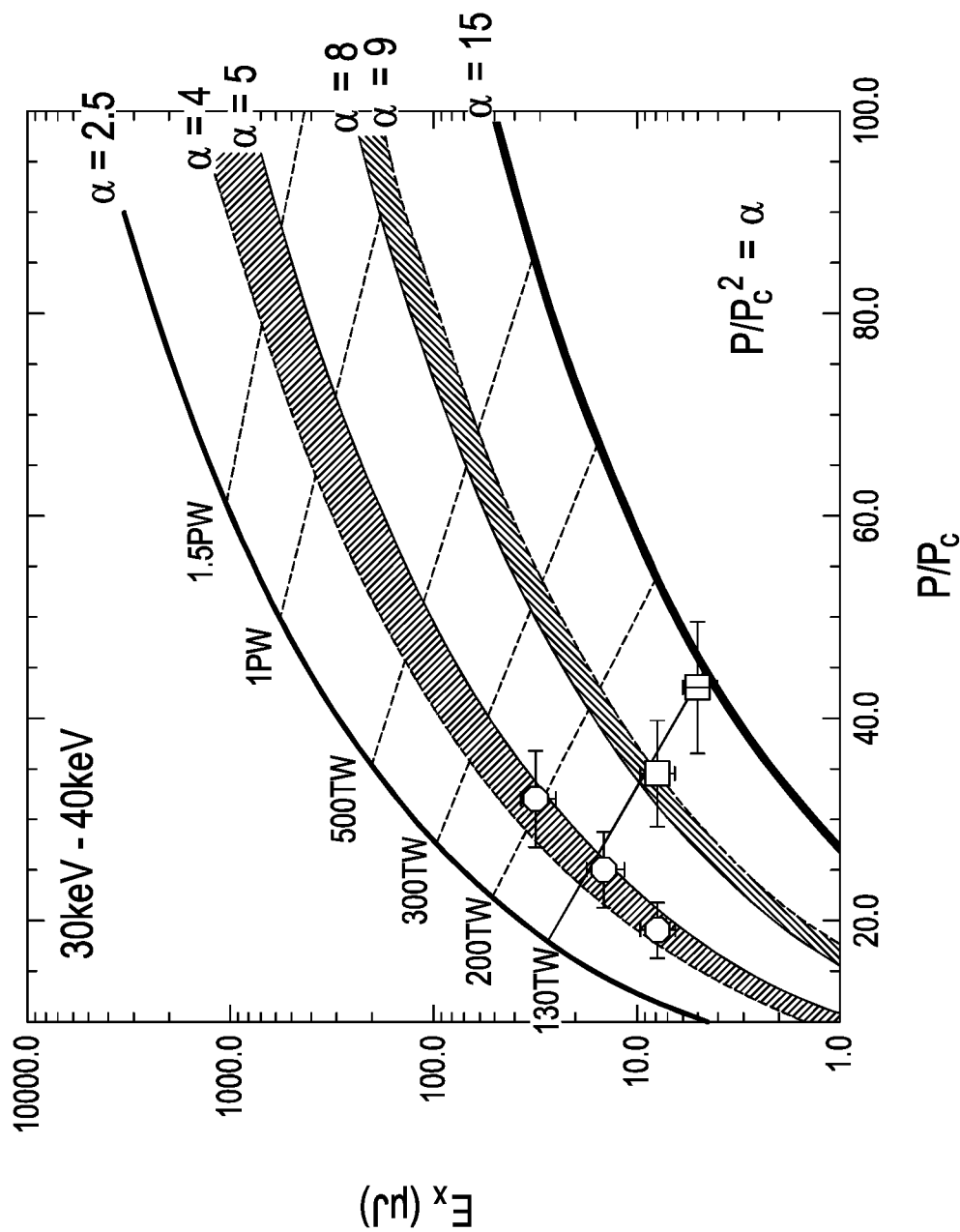


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FIG. 11FIG. 12



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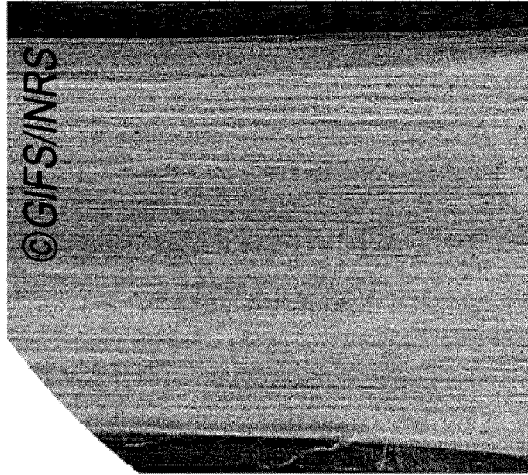
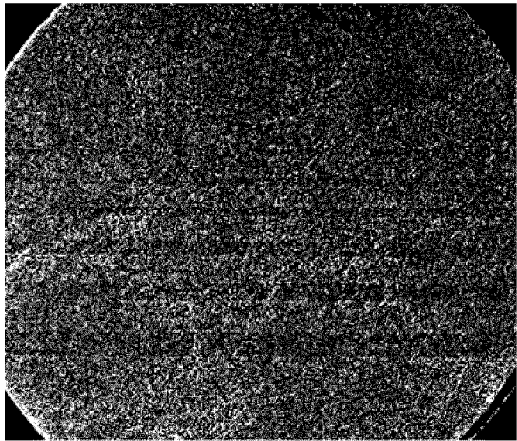


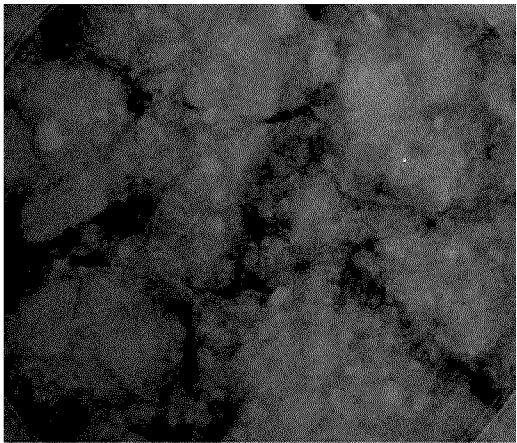
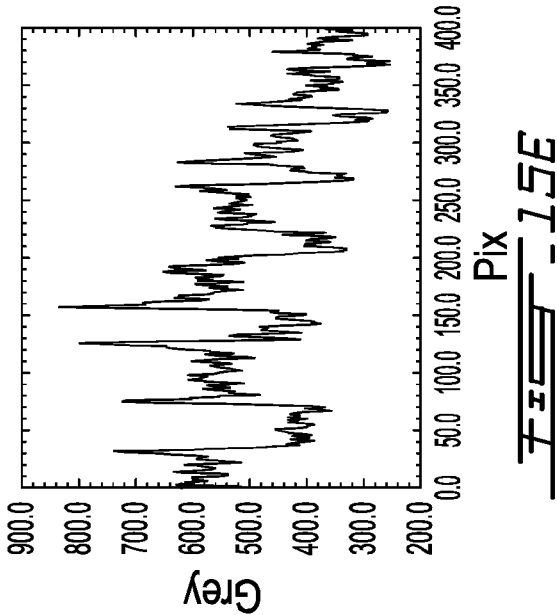
Fig. 14B



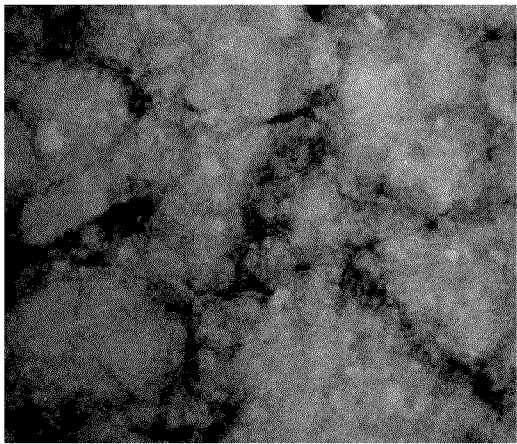
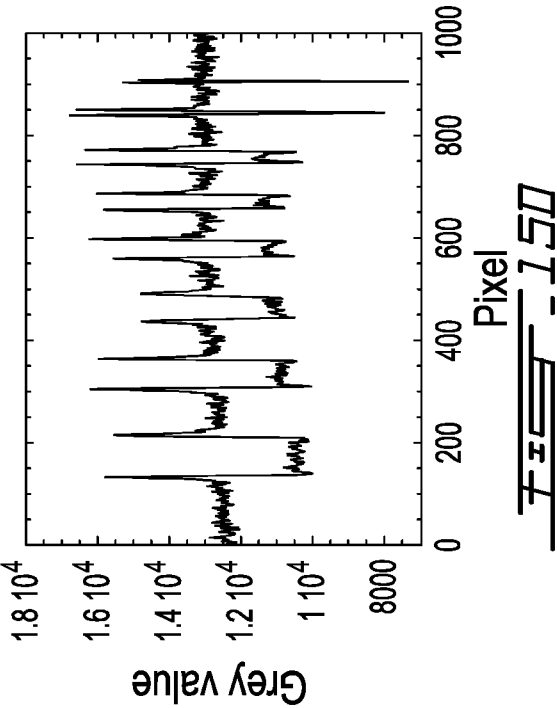
Fig. 14A



FEI-15C

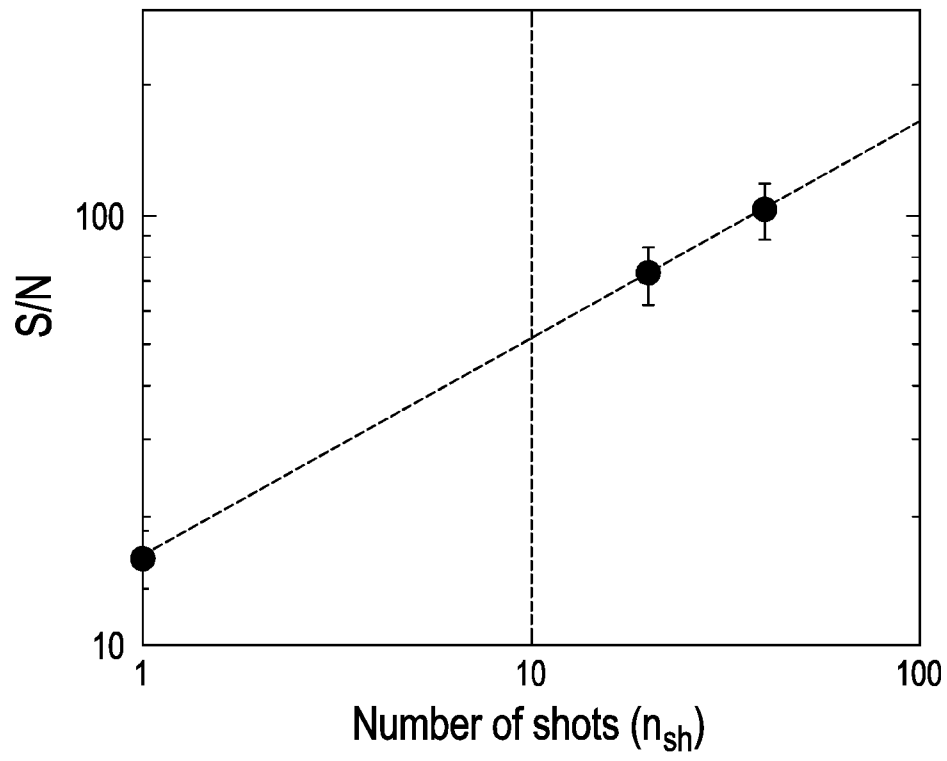


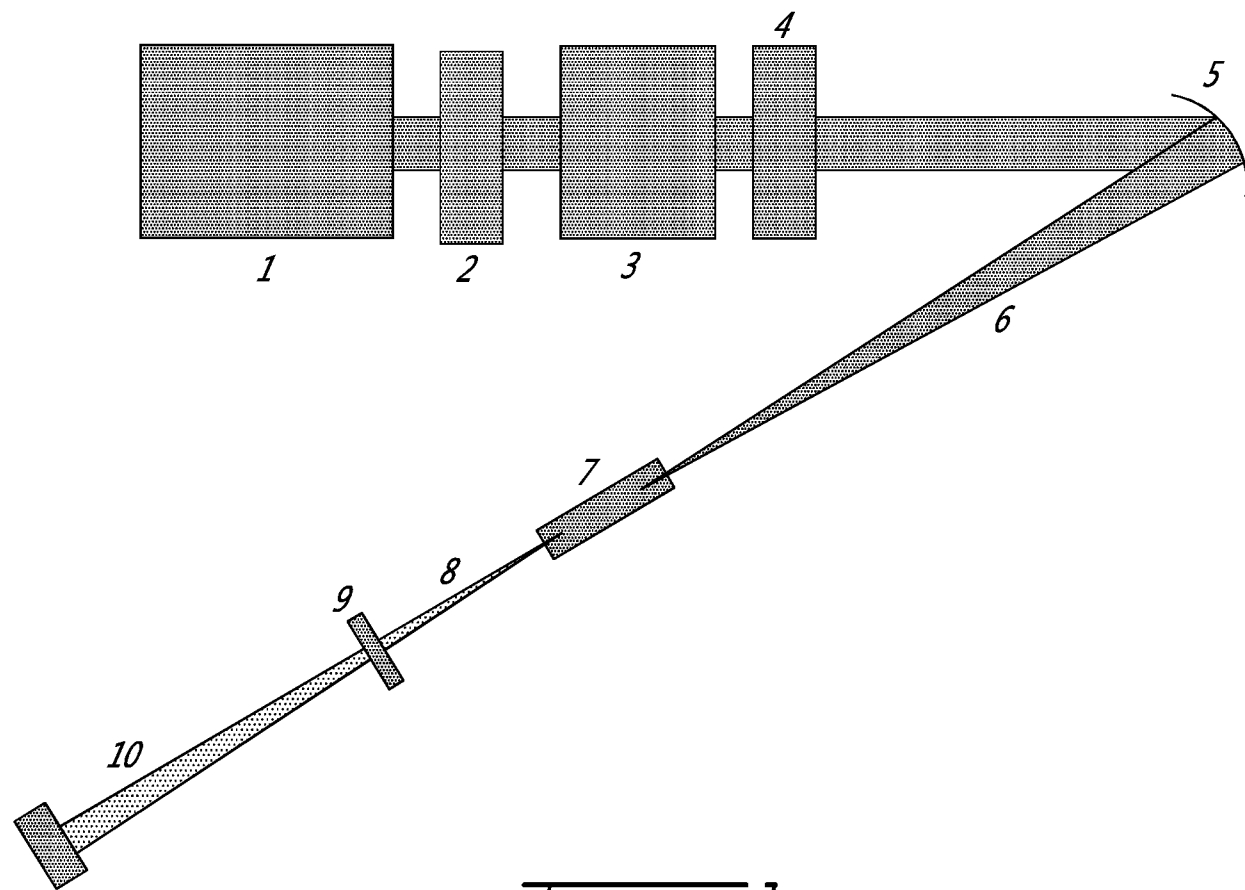
FEI-15B



FEI-15A

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FIG. 16FIG. 17



F. 1